



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

OKU et al

Serial No.: 09/903,764

Filed: July 13, 2001

For: FILM FORMING METHOD, SEMICONDUCTOR
DEVICE AND SEMICONDUCTOR DEVICE
MANUFACTURING METHOD

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) Examiner: Dang, T.
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) Art Unit: 2823
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INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR 1.97(d)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

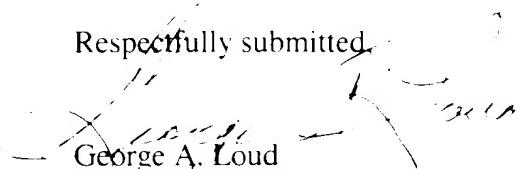
Sir:

It is respectfully requested that the examiner consider and cite of record the four (4) references listed on the attached, copies of which are submitted herewith. Also submitted herewith is a copy of a European Search Report issued July 23, 2003 in connection with EP Application No. 01 11 66 94, believed to correspond to the captioned application. The examiner will note that in addition to the four references submitted here, the European Search Report cites a fifth reference, i.e., the English language abstract of Japanese Publication 10-125669 which has already been made of record by the office action of October 24, 2002.

The undersigned hereby certifies that each item of information contained in this Information Disclosure Statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three (3) months prior to today's date.

Our credit card payment form in the amount of \$180.00 is also submitted herewith to cover the fee required by 37 CFR 1.17(p).

Respectfully submitted,


George A. Loud
Reg. No. 25.814

Dated: September 3, 2003

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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.